



U.S. Patent App. No. 09/647,659
Docket: 033082.052

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

First Named Inventor: DELLER

Application No.: 09/647,659

Filing Date: 10/04/2000

Examiner: GRAYBILL, DAVID E

Group Art Unit: 2814

For: ALIGNMENT PROCESSING MECHANISM AND SEMICONDUCTOR
PROCESSING UNIT WITH ALIGNMENT PROCESSING MECHANISM

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RESPONSE TO FINAL OFFICE ACTION

Box AF
Commissioner for Patents
Washington, D.C. 20231

A response to the final Office Action mailed May 21, 2002 is being timely filed
by the August 21, 2002 due date. The application is to be amended as follows.

AMENDMENT TO THE CLAIMS

Claim 17 is to be amended as shown in the enclosed marked up version.

Applicants have also enclosed a clean version of this claim for the Examiner's
review.

Applicants submit that the amendment should be entered because it complies with
a requirement pertaining to the form of the claim as set forth in the previous Office
Action (i.e. the 112 rejection).

No additional fees are due as a result of this amendment.